



Docket No.: M4065.0319/P319-A  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Husam N. Al-Shareef, et al.

Examiner: Erik Kielin

Application No.: 09/912,558

Art Unit: 2813 ✓

Filed: July 26, 2001

For: FABRICATION OF DRAM AND OTHER  
SEMICONDUCTOR DEVICES WITH AN  
INSULATING FILM USING A WET  
RAPID THERMAL OXIDATION PROCESS

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RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

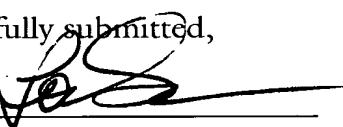
Dear Sir:

In response to the Restriction Requirement set forth in the Office Action dated December 19, 2003, Applicants elect Group I, claims 13, 14, 16, 17 and 42, for continued examination. This election is made without traverse. An action on the merits of all the claims and a Notice of Allowance thereof are respectfully requested.

Dated: January 6, 2004

5

Respectfully submitted,

By   
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